JUN 2 1 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re:

Smith et al.

Docket:

TI-22782B

Appl. No.: 09/757,073

Examiner:

E. Cameron

Filed:

01/08/01

Art Unit:

1762

For:

Polyol-Based Method For Forming Thin Film Aerogels On Semiconductor

Substrates

PETITION TO ACCEPT UNINTENTIONALLY DELAYED CLAIM FOR PRIORITY

June 18, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Examiner:

FACSIMILE CERTIFICATE

I hereby certify that this correspondence is being transmitted by Facsimile to the Patent and Trademark Office in accordance with 37 C.F.R. §1.5chon

1 X Lucio

Tina Smitt

Please accept the following claim for priority in this application.

This application is a continuation of U.S. application number 09/115,854 filed 07/15/98—now patent 6,171,645—, which is a continuation of U.S. application number 08/748,926 filed 11/14/96—now patent 5,807,607—, which claims priority from provisional application numbers: 60/006,852 filed 11/16/1995, 60/006,853 filed 11/16/1995, 60/012,764 filed 3/4/1996, 60/012,800 filed 3/4/1996, and 60/014,005 filed 3/4/1996.

This application was originally amended to claim priority from the '854 and '926 applications. However, Applicants' agent inadvertently neglected to claim the '852 application's priority from its provisionals.

The original failure to claim this priority and the entire intervening delay was unintentional.

Please charge the required fee to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Respectfully submitted,

Reg. No. 40,987

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